

Appl. No. 09/675,220  
 Amendment dated:  
 Reply to OA of: May 6, 2004

RECEIVED  
 CENTRAL FAX CENTER  
 SEP 03 2004

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Minoru NAKANO et al. Confirmation No.: 1221  
 Appl. No. : 09/675,220  
 Filed : September 29, 2000  
 Title : METHOD AND APPARATUS FOR CONTROLLING A  
 SEMICONDUCTOR FABRICATION TEMPERATURE  
 TC/A.U. : 2825  
 Examiner : Caridad M. Everhart  
 Docket No. : 3094/FLK (032878-87728)

**AMENDMENT**

Commissioner  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

Sir:

This is in response to the Official Action of May 6, 2004, in connection with the  
 above-identified application.

Please amend the application as follows:

**Amendments to the claims** are reflected in the listing of claims which begins  
 on page 2 of this paper

**Remarks** begin on page 6 of this paper.

**CERTIFICATION OF FACSIMILE TRANSMISSION**  
 I hereby certify that this paper is being facsimile  
 transmitted to the Patent and Trademark Office on  
 the date shown below

*Frances Doyle*  
 Type or Print name of sender  
 Signature *Frances Doyle*  
 Date *9-3-2004*

Page 1 of 11

11188228.01